

Notice of References Cited	Application/Control No. 10/599,232		Applicant(s)/Patent Under Reexamination YOO ET AL.	
	Examiner VERNON P. WEBB		Art Unit 2811	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0119082 A1	06-2004	Sugawara, Hideto	257/094
	B	US-			
	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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*	N	JP 10084159 A	03-1998	Japan	KAMIMURA et al.	H01S 03/18
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kimimura et al., Machine Translation of JP 10-084159 A
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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